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10/13/2010

DOCKET NO: 263787US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
HIROSHI MASHIMA, ET AL. : EXAMINER: KELLY M. GAMBETTA
SERIAL NO: 10/518,371 : ALLOWED: JULY 15, 2010
FILED: DECEMBER 28, 2004 : GROUP ART UNIT: 1715
FOR: METHOD FOR PLASMA- :
ENHANCED CHEMICAL VAPOR
DEPOSITION AND APPARATUS FOR
PLASMA-ENHANCED CHEMICAL
VAPOR DEPOSITION

AMENDMENT AFTER ALLOWANCE UNDER 37 C.F.R. §1.312

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Notice of Allowability dated July 15, 2010, please amend the
above-identified application as indicated in the present Amendment.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.